

Application/Control	l No.
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10/675,178 Examiner Applicant(s)/Patent under
Reexamination
HWANG ET AL.
Art Unit

Application Number:	10562211					
Filing Date:	07-Dec-2006					
Title of Invention:	Lithographic Apparatus, Support, Device Manufacturing Method, and a Method of Supporting					
First Named Inventor/Applicant Name:	Dirk-Jan Bijvoet					
Filer:	Jean-Paul Hoffman/Amanda Childs					
Attorney Docket Number:	081468-0324818					
Filed as Large Entity						
U.S. National Stage under 35 USC 371 Filing Fees						
Description		Fee Code	Quantity	Amount	Sub-Total in USD(\$)	
Basic Filing:						
Pages:						
Claims:						
Miscellaneous-Filing:						
Petition:						
Patent-Appeals-and-Interference:						
Post-Allowance-and-Post-Issuance:						
Extension-of-Time:						